



H.W.
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4320**
Norio KIMURA et al. : Docket No. 2001_0122A
Serial No. 09/777,707 : Group Art Unit 3723
Filed February 7, 2001 : Examiner Maurina T. Rachuba

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POLISHING APPARATUS

RESPONSE

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 4, 2003, having a three (3) month shortened-statutory period for response set to expire February 4, 2004, a petition for a (1) month extension of time up to and including March 4, 2004, being filed concurrently herewith, please amend the above-identified application as follows: